

#4  
Amendt a  
OSmalls-Logan  
6/23/03

Appl. No. 09/888,256  
Page 1 of 21

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: Howard et al.	Group Art Unit: 2861
Application No: 09/888,256	Examiner: Hai Chi Pham
Confirmation No: 8744	
Filed: June 22, 2001	Attorney Docket No: 004978 USA/ETEC/RWM
Title: ELECTRON BEAM PATTERNING WITH A HEATED ELECTRON SOURCE	June 18, 2003 San Francisco, California
	FAX RECEIVED JUN 18 2003 TECHNOLOGY CENTER 2800

**AMENDMENT UNDER 37 C.F.R. § 1.111**

Commissioner for Patents  
Washington, D.C. 20231

Via Facsimile Transmission  
(703) 872-9318

Examiner Pham:

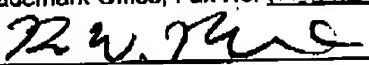
This communication is being timely filed in response to the Non-Final Office Action mailed on March 18, 2003, within three months and with no extension of time.

06/24/2003 KJONES3 00000004 100258 09888256

01 FC:1201 168.00 DA  
02 FC:1202 36.00 DA

**Certificate of Transmission**

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office, Fax Nu. (703) 872-9318 on June 18, 2003.

  
Reece Nienstadt